

APPLICATION DATA SHEET

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Attorney Docket Number: ATMI-466

Publication Filing Type:

new-utility

Application Type:

utility

Title of Invention:

COMPOSITION AND CHEMICAL VAPOR DEPOSITION METHOD FOR

FORMING ORGANIC LOW K DIELECTRIC FILMS

Customer Number Correspondence Address:

25559

INVENTOR(s):

Primary Citizenship:

US

Given Name:

Neil

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Н

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